

## The boron-oxygen (BiOi) defect complex induced by irradiation with 6 MeV electrons in p-type silicon diodes

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Abstract: The radiation induced BiOi defect complex by 6 MeV electrons in low resistivity (10 Wcm) p-type epitaxial silicon diodes has been studied using the Thermally Stimulated Current (TSC) and the Thermally Stimulated Capacitance (TS-Cap) technique. The fluence values were in the range between  $1 \times 10^{15}$  e/cm<sup>2</sup> and  $6 \times 10^{15}$  e/cm<sup>2</sup>. The extracted results on the activation energy, defect concentration as well as the isothermal annealing behavior at 80 °C will be presented and discussed in comparison with data from TSC and DLTS (Deep Level Transient Spectroscopy) measurements achieved by the team of the CERN-RD50 “Acceptor removal project”. In addition, the extracted microscopic data are compared with results from capacitance-voltage (C-V) characteristics.

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